

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10026419	FILING DATE 12/26/2001	CLASS 430	SUBCLASS 322	GAU 1752	EXAMINER Chacko-Davis
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**CONTINUING DATA VERIFIED: *WD*

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** FOREIGN APPLICATIONS VERIFIED: *WD*

JAPAN 2000-394354 12/26/2000

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Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials <i>WD</i>		U.S. DEPT. OF COMM./PAT. & TM-PTO-433 (Rev. 12-94)	
TITLE : Apparatus for processing substrate and method of processing the same			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for 0.0
		DRAWING	
Amount Due	Date Paid	Sheets Drawn	Fig.s Drawn
TERMINAL DISCLAIMER		Print Fig.	
		Application Examiner	
PREPARED FOR ISSUE			
Primary Examiner			
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